

TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

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| Title of Invention | THIN FILM TRANSISTOR AND MANUFACTURING METHOD THEREOF | |
| Application Number : | | |
| Date : | | |
| First Named Applicant: | Mr. Fang-Chen Luo | |
| Confirmation Number: | | |
| Attorney Docket Number: | 12405-US-PA-0P | |
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| Submitted By: | | Elec. Sign. |
| Dr. Belinda Lee Registered Number: 46,863 | | /Belinda Lee/ Sign. Capacity Agent |

| Documents being submitted: | Files |
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| us-request | 12405-usrequ.xml us-request.dtd us-request.xsl |
| us-fee-sheet | 12405-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd |
| us-declaration | 12405declaration01.tif |
| us-declaration | 12405declaration02.tif |
| application-body | 12405usfcip.xml application-body.dtd Image1.tif Image2.tif Image3.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl wipo.ent |
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